

ACCELEROMETER DESIGN AND THEORY

THE MODAL SHOP

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ACCELEROMETER THEORY

- Learning Objectives
 - Common types encountered in Cal Labs
 - Electro-Mechanical
 - Characteristics & Considerations
 - Applications & Cautions
 - Construction & Materials
 - Reference Sensor Considerations





ACCELEROMETER TYPES

- Current accelerometer types
 - Resistive Strain Gauge, Thin-Film, Piezoresistive
 - Capacitive Micromachined
 - Piezoelectric



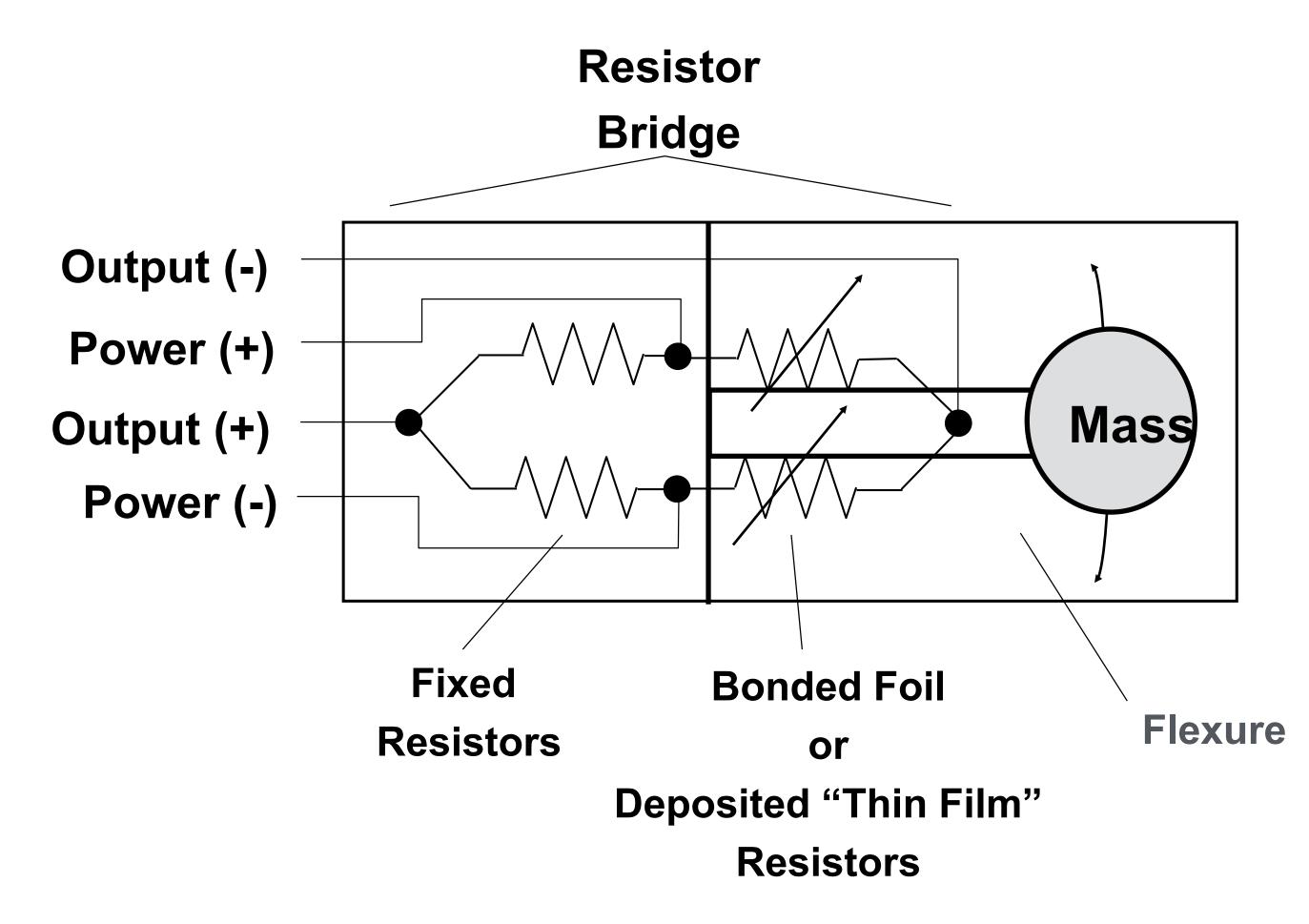




- Other less common types
 - Servo / Force-Feedback
 - Vibrating Quartz
 - Slide-wire potentiometer
 - Variable Inductance
 - Fiber Optic
 - Piezotransistor



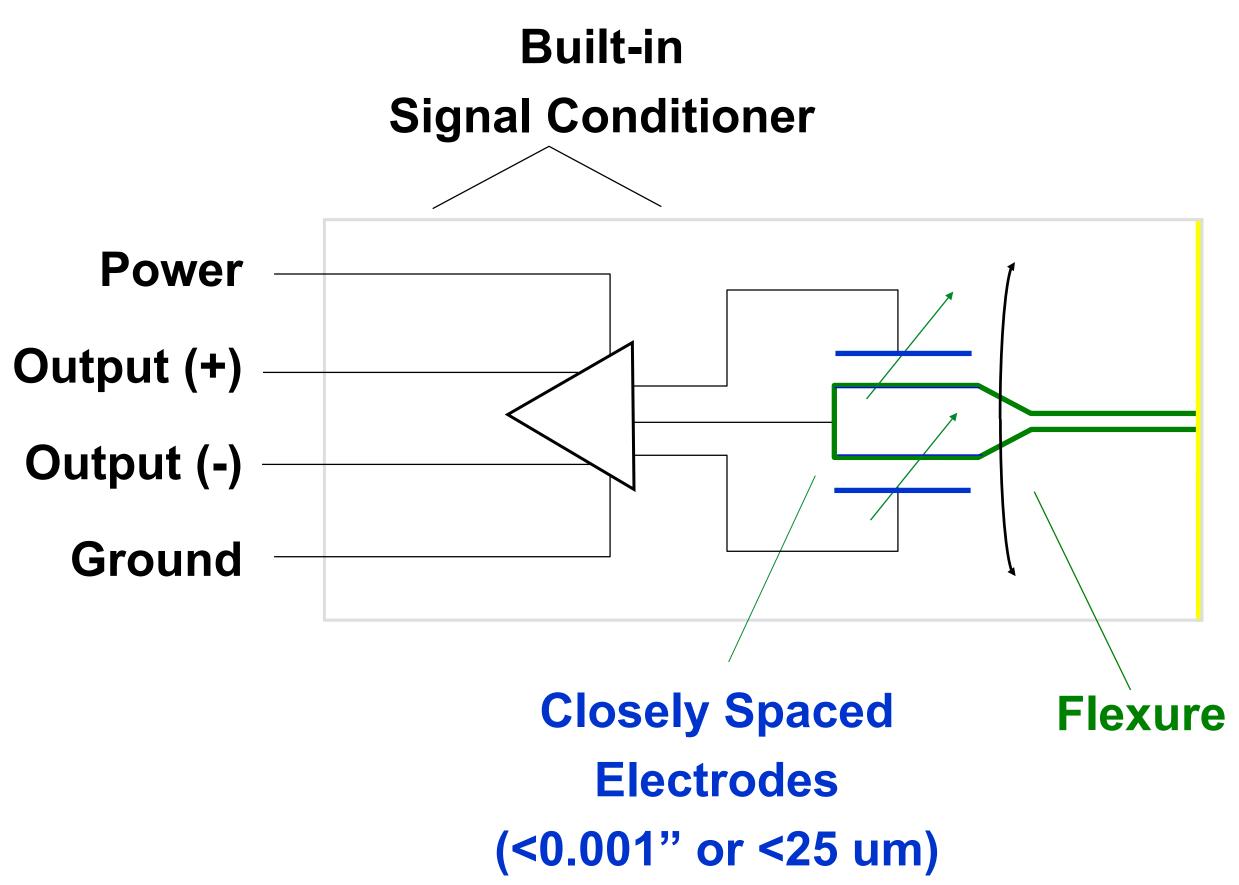
RESISTIVE

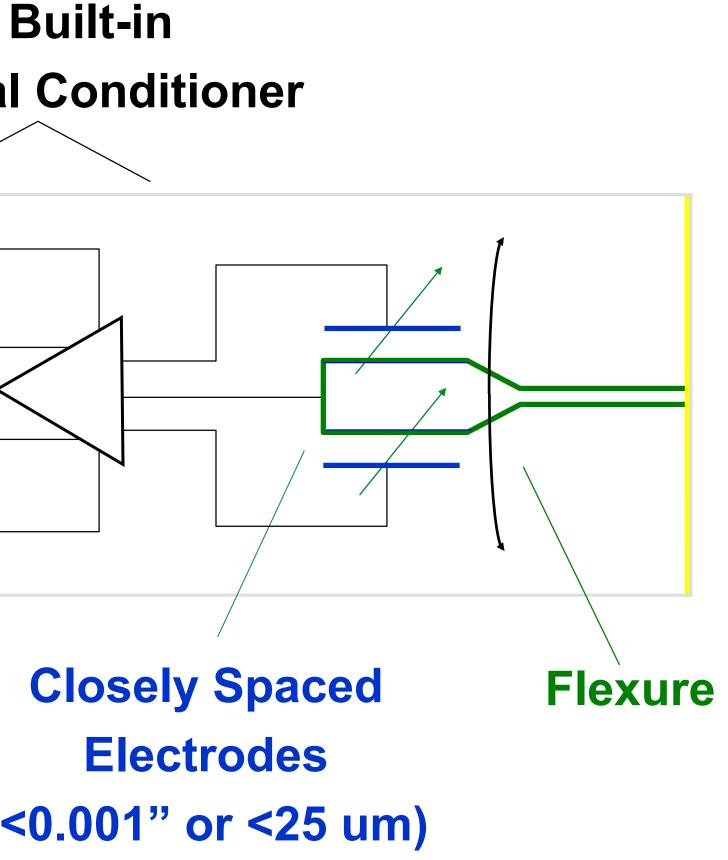
















RESISTIVE AND CAPACITIVE

- Typical Characteristics:
 - DC aka 0 Hz measurement
 - Limited dynamic range (~80 dB = 10,000:1)
 - Limited high frequency range (<10 kHz)
 - Sensitivity varies with excitation (mV/g per V)
 - Multiple wire interface





RESISTIVE AND CAPACITIVE

- Typical Applications:
 - Long Duration/Low Frequency Events:
 - Automobile Acceleration/Deceleration
 - Aerospace Modal Surveys
 - Suspension Road Response
 - Robotics
 - Whole Body Ordnance Effects Testing
 - Crash Dummy Instrumentation
 - Tilt Sensors
 - Airbag Industry (Low Cost)







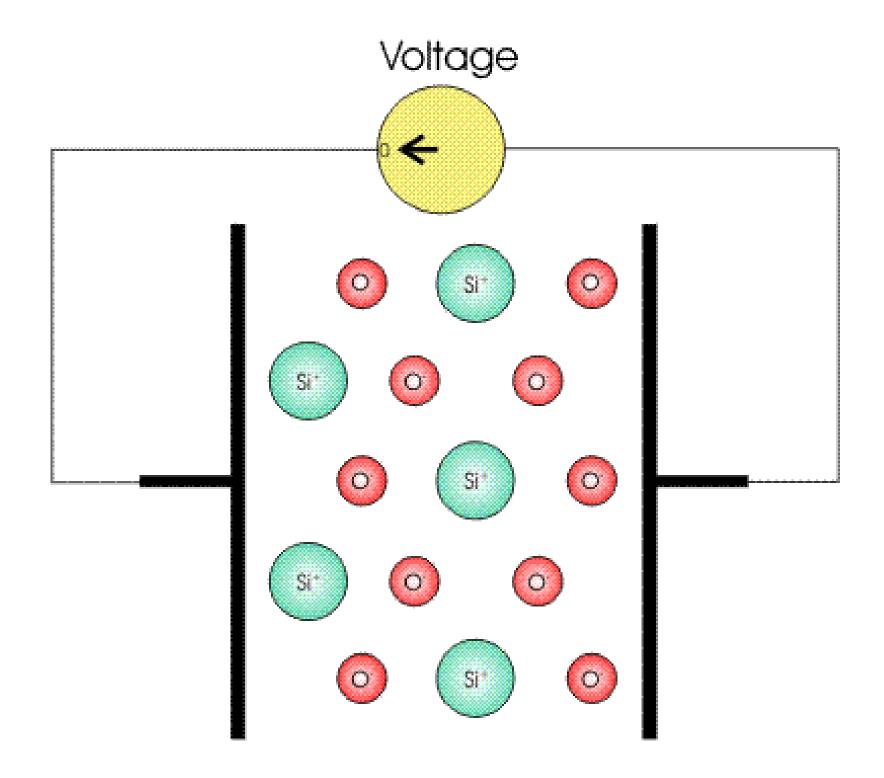


PIEZOELECTRIC ACCELEROMETERS

- Piezoelectric crystal electrical charge output per strain input
- Seismic mass converts acceleration to strain







PIEZOELECTRIC

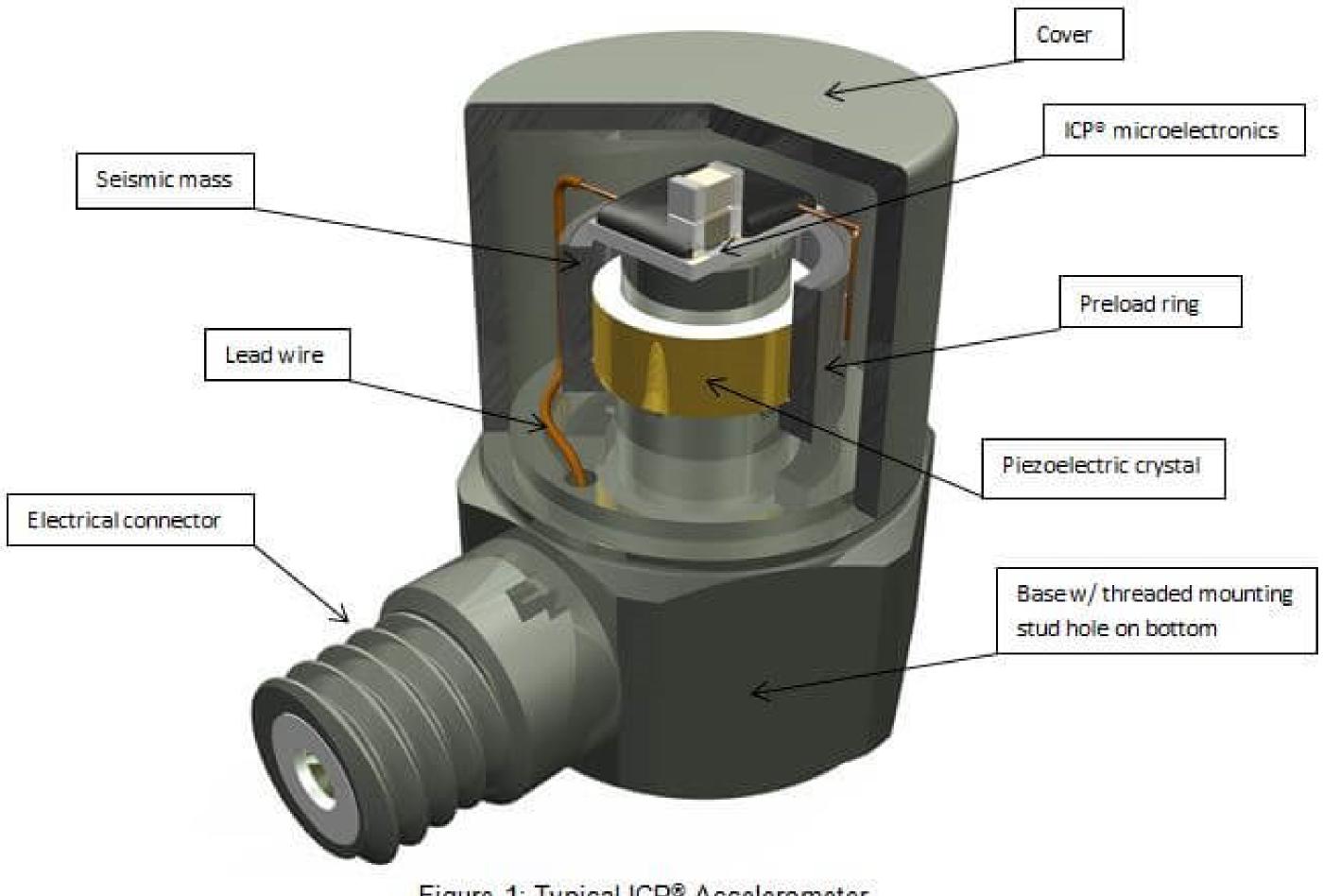






Figure 1: Typical ICP® Accelerometer

PIEZOELECTRIC

- Typical Characteristics
 - Dynamic events only (>0.1 Hz)
 - Wide dynamic range (>120 dB = 1,000,000:1)
 - Wide bandwidth (>10 kHz)
 - Operates over two wires
 - Rugged
 - High temperature versions (1240 F [650 C])





PIEZOELECTRIC

- Typical Applications
 - Rotating equipment operation
 - Automotive
 - Aerospace
 - Consumer goods
 - Industrial machinery











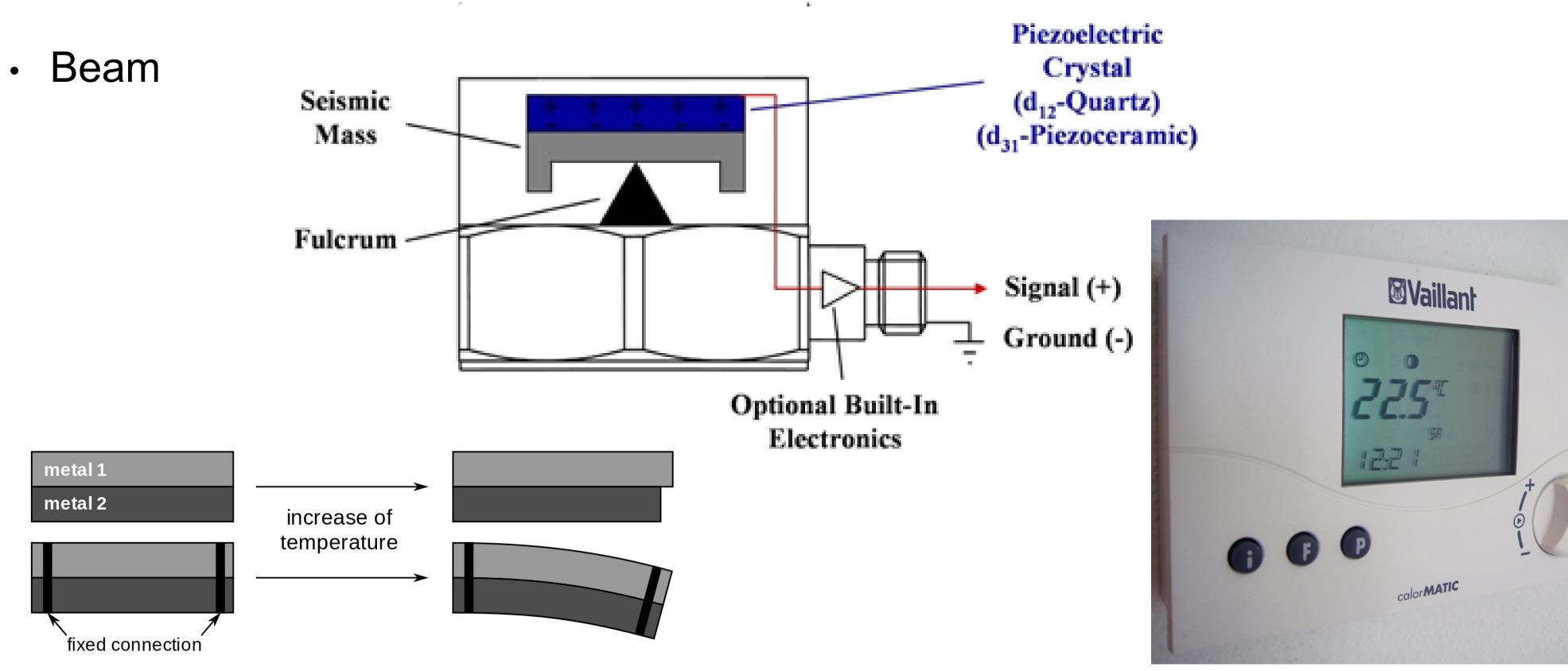
- Element Configurations
 - Compression
 - Inverted Compression
 - Beam
 - Shear
 - Tri Shear
 - Annular Shear







Element Configurations







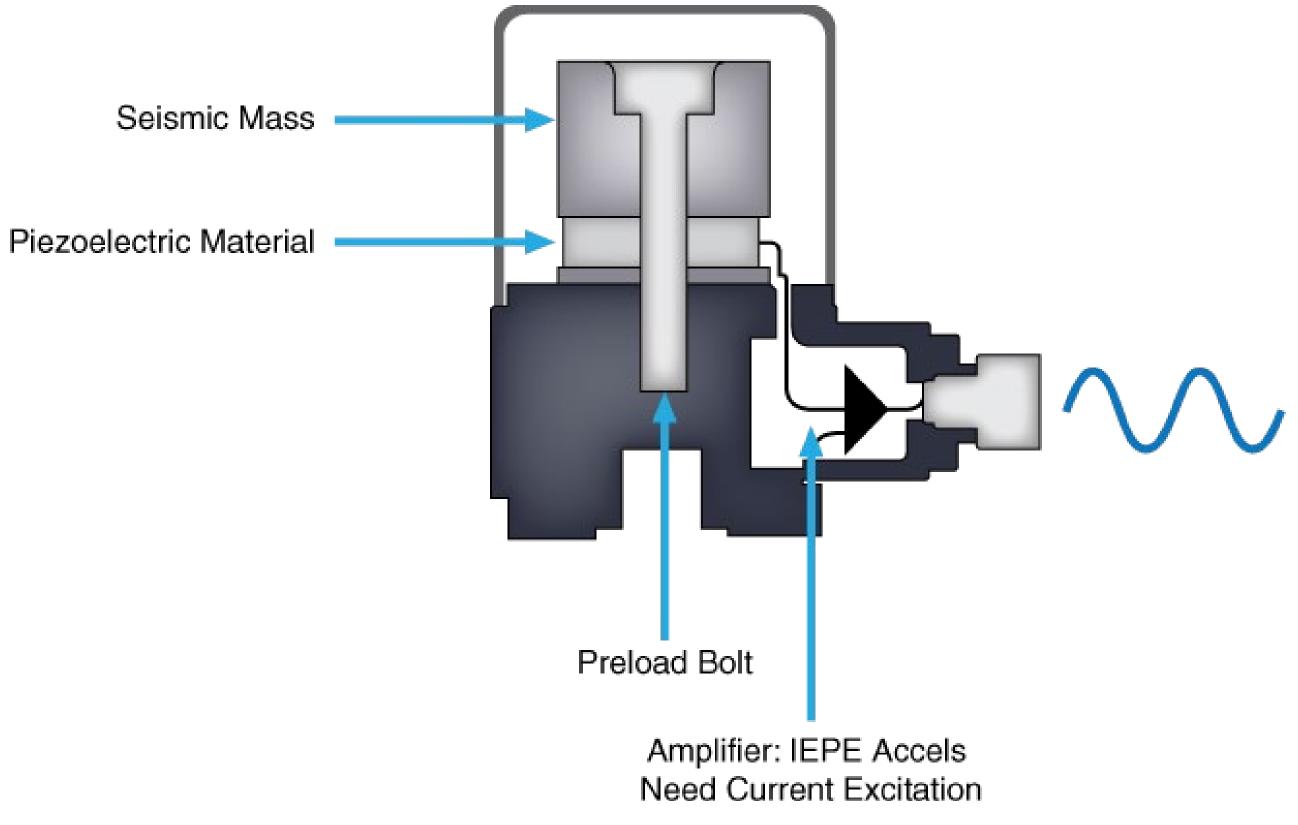


- Element Configurations
 - Compression

Inverted Compression



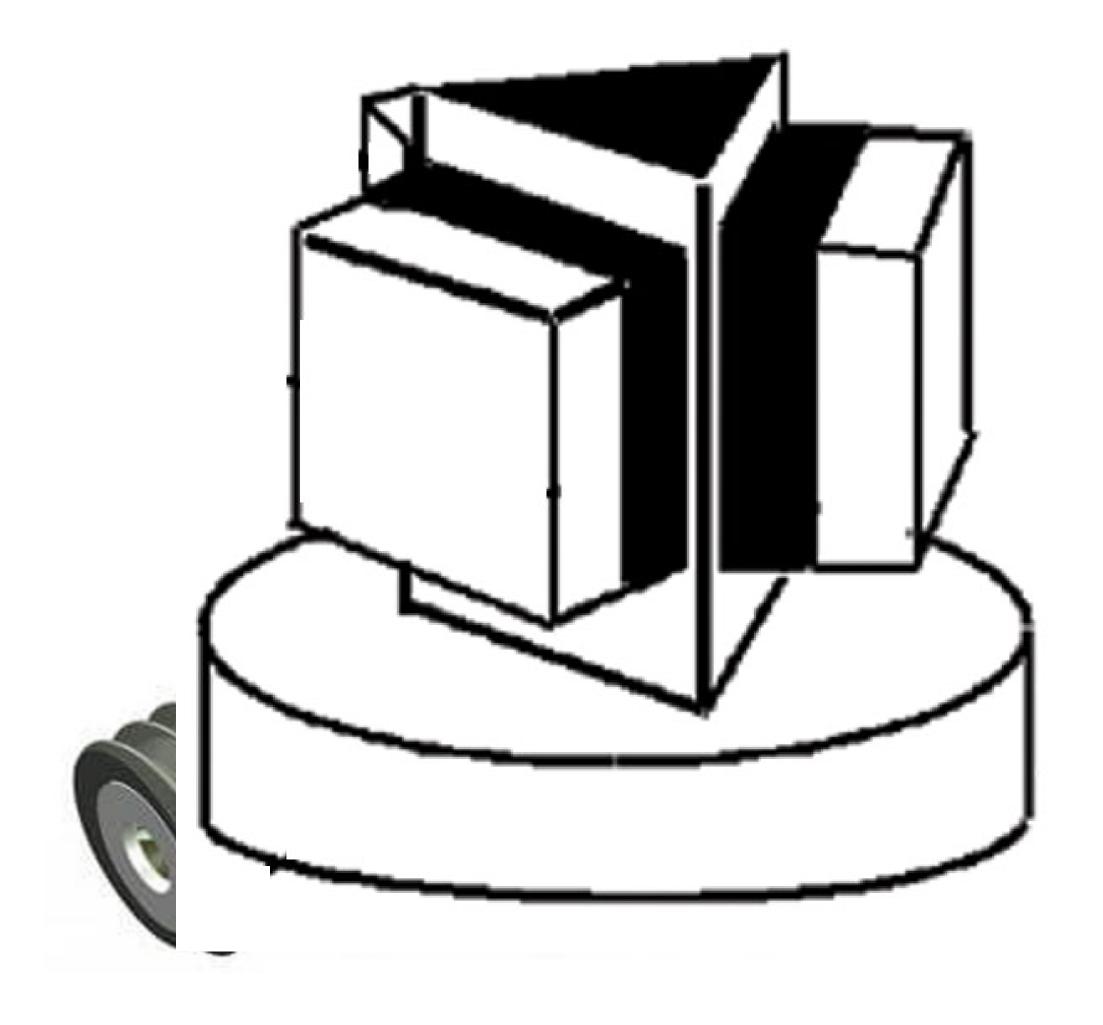




Element Configurations

Shear

- Annular Shear
- Tri Shear







PIEZOELECTRIC SENSING MATERIALS

High Sensitivity

High Operating Temperature

(Lack of) Thermal Sensitivity

Long Term Output Stability

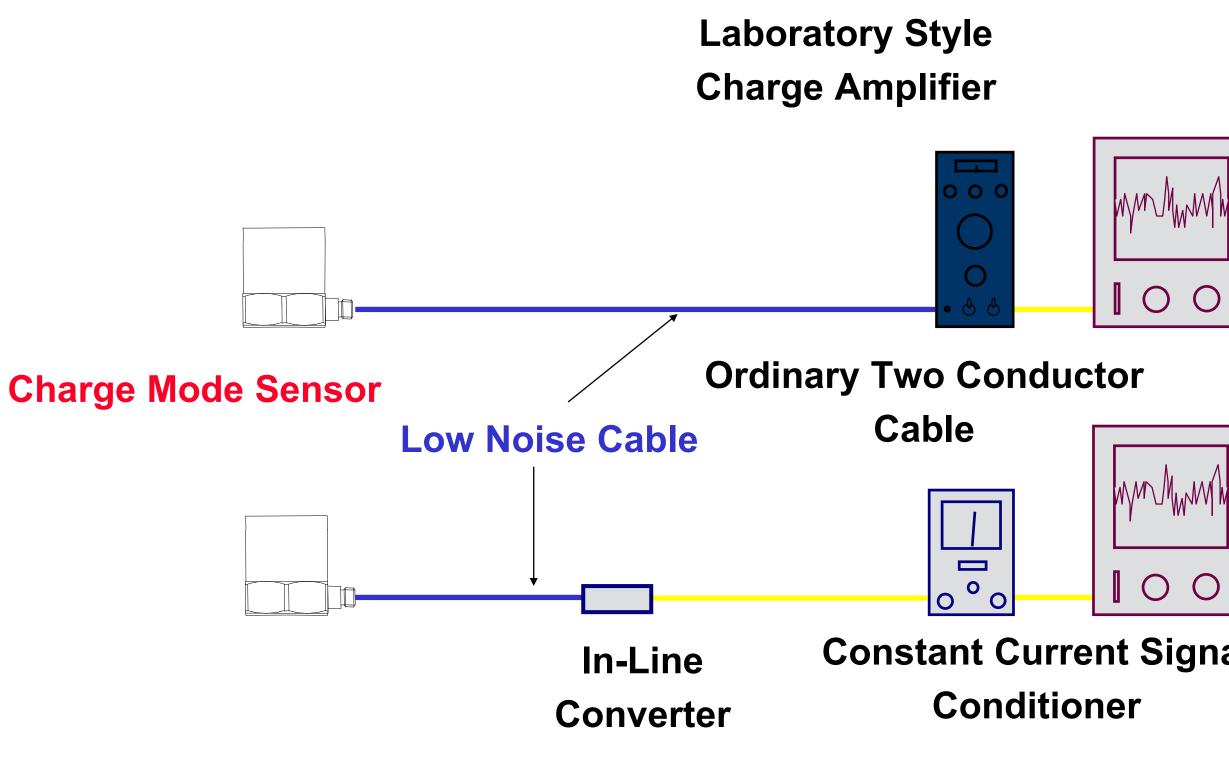




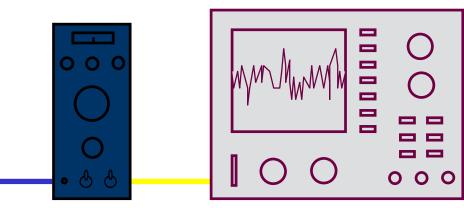
Quartz	Ceramic		

PIEZOELECTRIC ELECTRICAL DESIGN

• Charge Output (externally amplified)







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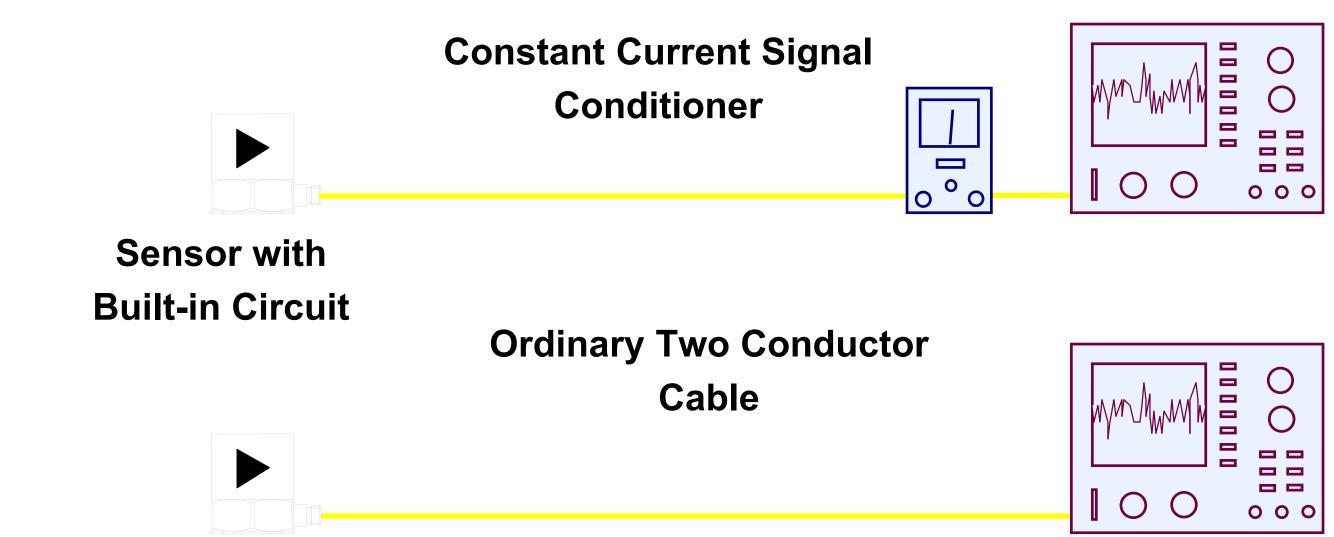
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Readout Device

Constant Current Signal

PIEZOELECTRIC ELECTRICAL DESIGN

• IEPE (internally amplified) aka ICP®



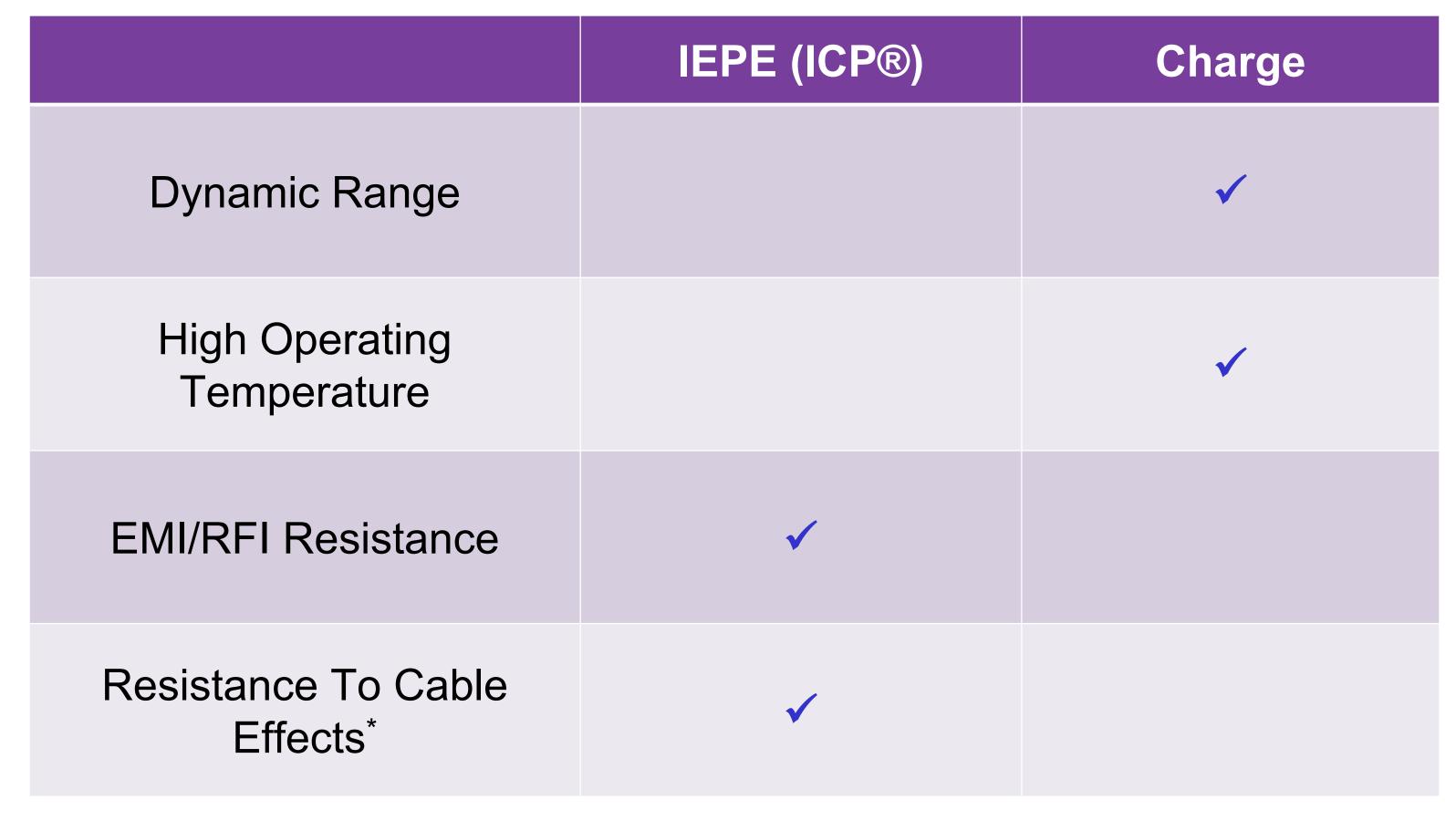




Readout Device

Readout Device with built-in **Constant Current** Source

PIEZOELECTRIC ELECTRICAL DESIGN



* - Cable length, cable motion, cable contamination





CALIBRATION CERTIFICATE

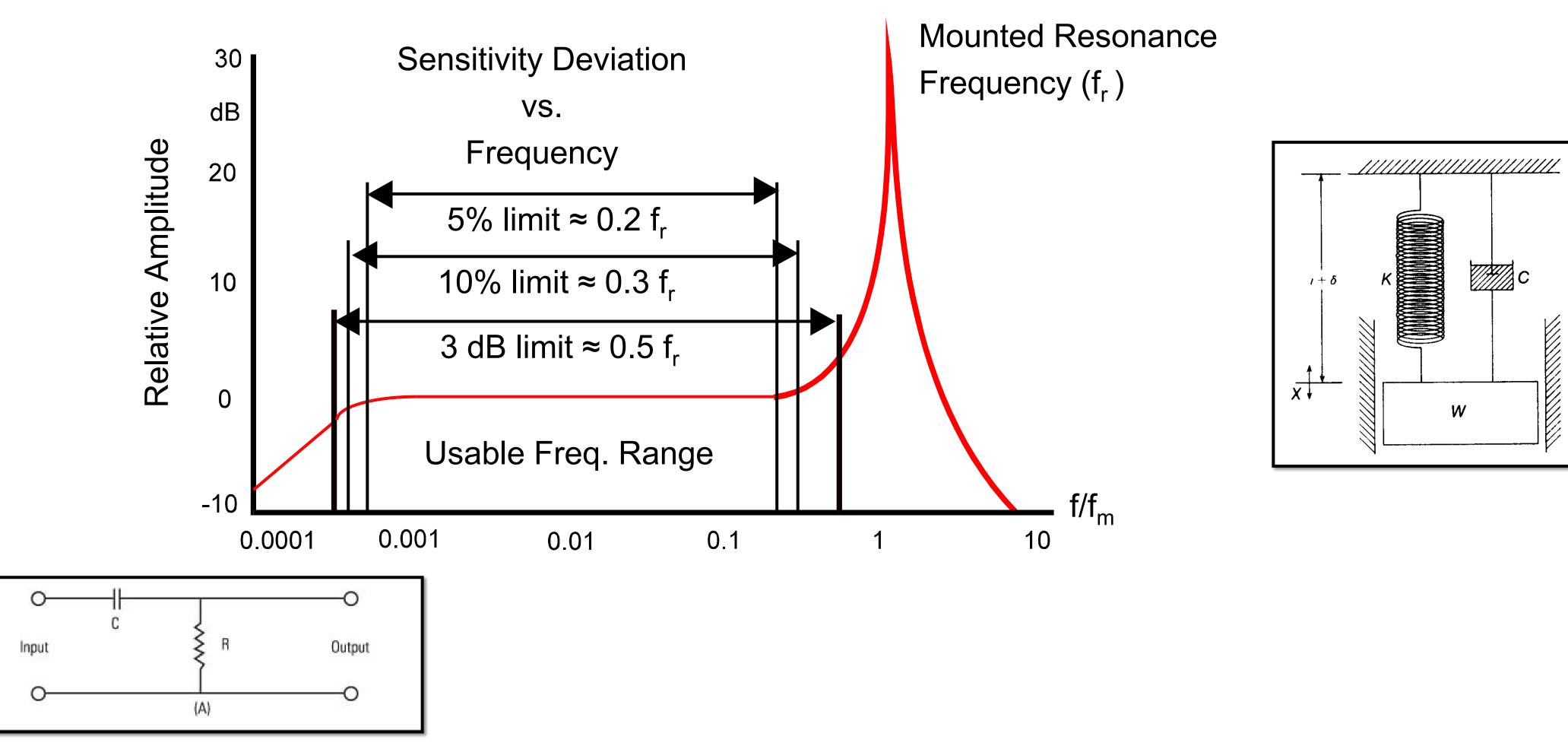
- Displays both Sensitivity (at reference frequency) and Frequency Response
- Each have different tolerance specifications
- These specifications are not the same thing as accuracy and uncertainty





	~ Ca	libratio	n Certifi	icate ~		
Model Number:	3520		J	Per ISO 16063-2	1	
Serial Number:						
Description: ICP® Accelerometer		Mathody	Method: Back-to-Back Comparison Calibration			
		Method:				
Manufacturer:	PCB					
		Calibra	tion Data			
Sensitivity @ 100.0 H	iz 9.95	mV/g	Output Bias		9.8 VI	C
	(1.015	mV/m/s²)	Transverse Sen	sitivity	1.8 %	
Discharge Time Const	Discharge Time Constant 3.0 seconds		Resonant Frequ	Resonant Frequency 90.4 kHz		
	Temperature: 72 °F (22		tivity Plot R	elative Humidity: 60 %	6	
3.0-				:		
2.0-						
10 0.0-		×		1		
-1.0						
-2.0-						
-3.0-	1	100.0		1000.0		10000.0
Hz			r Points			
Frequency (Hz)	Dev. (%)	Frequency (Hz		Frequency ((Hz) I	ev. (%)
10.0	-0.3	300.0	0.2	7000.0		1.9
15.0	-0.3	500.0	0.1	10000.0		3.4
30.0	-0.2	1000.0	0.3			
50.0	-0.3	3000.0	0.4			
REF. FREQ.	0.0	5000.0	0.9			
Mounting Surface: Tangeton Adapter Acceleration Level (rung):	Easterner: Cyanoacrylate Adhesiw 1946 - Fél I advif	e		n Orientation: Vertical		
 The acceleration level may be Errind i ~ 0.014 x (frag)⁶. 	ky slakar dispinsionet at low frequen	LINE. If the listed level cannot be	obtained, the calibration system uses t it constant used for calculations by th	ie fillowing formula to see the vis a calibrative system in: -1 g = 9.1	ntion amplitude: Accele 80665 m/s?.	atim Level (g)
As Found: n/a		Conditi	on of Unit			
	nit, In Tolerance					
		Λ	otes			
 This certificate s Calibration is pe See Manufacture 	shall not be reproduce rformed in compliant r's Specification Sho certainty (95% confi	eed, except in full nee with ISO 900 eet for a detailed idence level with	6 and PTB Traceable , without written app 1, ISO 10012-1, ANS listing of performance coverage factor of 2 -1999 Hz; +/- 1.0%, 2	FOR THE STATE OF T	iezotronics, I 994 and ISO ges tested du	17025.
Technician:		an Eckel De	<u>.</u>	Date:		
						,

FREQUENCY RESPONSE



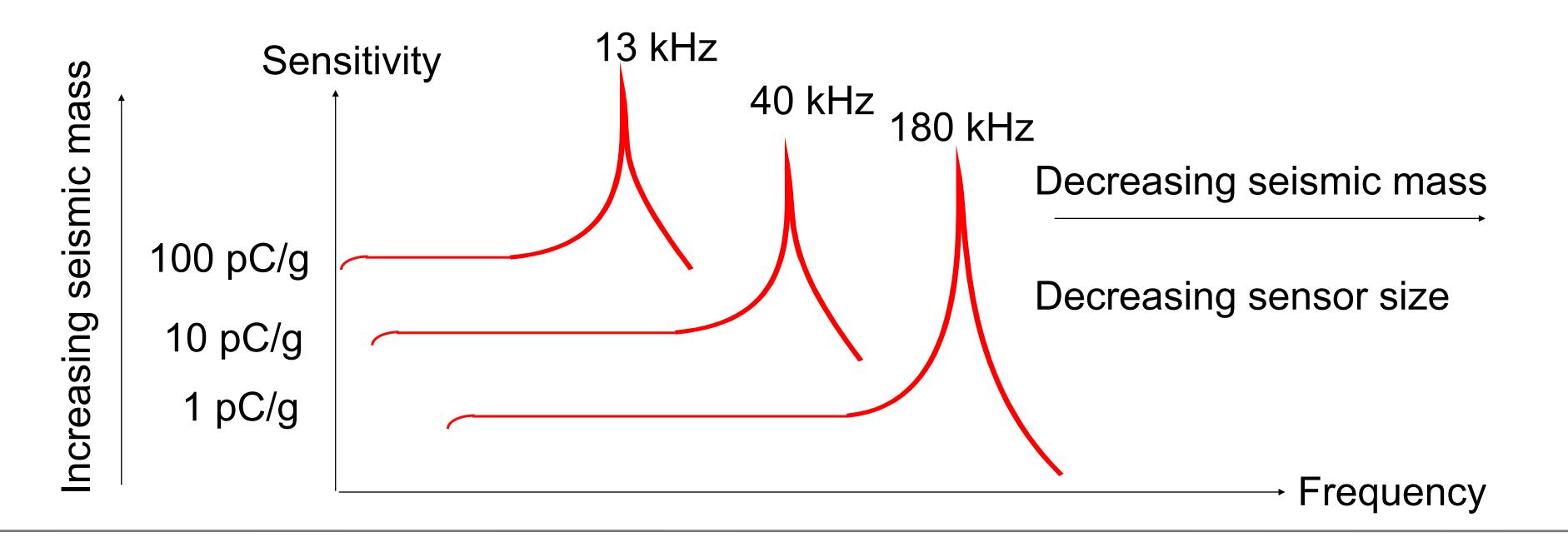






FREQUENCY RESPONSE

- Accelerometer Design •
 - Trading Sensitivity vs High Frequency Response

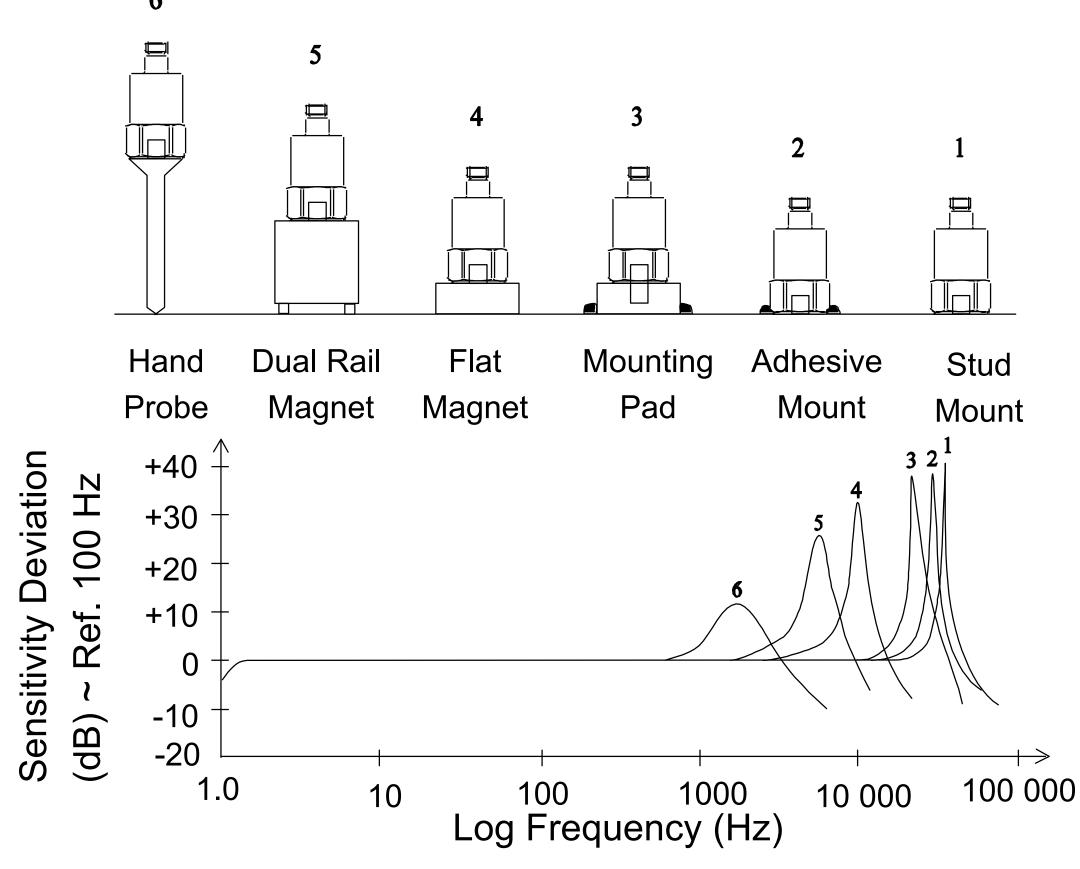






FREQUENCY RESPONSE

Mounting Method also affects response •







IDEAL REFERENCE ACCELEROMETER

Design Parameter

Element Design

Mechanical Design

Crystal Material

Electrical Design







Choice For Reference Accelerometer

Piezoelectric

Tri-shear

Quartz

IEPE aka ICP®







QUESTIONS?